

04-20-00

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PATENT APPLICATION
Attorney Docket No.: 99-230
Date: 4/19/00

Assistant Commissioner for Patents
Washington, D.C. 20231
ATTN: BOX PATENT APPLICATION

NEW APPLICATION TRANSMITTAL


Transmitted herewith for filing is the patent application of
Inventor(s): Michael J. Berman
For (title): Determination of Film Thickness During Chemical Mechanical
Polishing

jc542 U.S. PTO
09/553140
04/20/00

Enclosed are:

- 4 sheet(s) of drawings. (FORMAL)
- An Assignment of the invention to LSI Logic Corporation
- Declaration enclosed.
- Material information pursuant to 37 CFR §1.56.
- It is expressly requested that the U.S. Patent and Trademark Office commence national processing of the above-entitled international application under the provisions of PCT Article 23(2) and 35 USC 371(f).
- Return Postcard

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The filing fee has been calculated as shown below:

CLAIMS AS FILED

FOR	NUMBER FILED	NUMBER EXTRA	RATE	FEE
TOTAL CLAIMS	28 - 20 =	8	x \$18	144.00
INDEPENDENT CLAIMS	4 - 3 =	1	x \$78	78.00
			BASIC FEE	\$760.00
			FILING FEE	\$982.00

- The Commissioner is hereby authorized to charge any fees under 37 CFR §1.16 and 1.17 which may be required during the pendency of the application to Deposit Account No.13-0014.

"Express mail" mailing label number EL299951282 US Date of Deposit April 19, 2000
I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR §1.10 on the date indicated above and is addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Bruce J. Bowman
(Name of person mailing application)


(Signature of person mailing application)

jc804 U.S. PTO
04/20/00

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